PTO/SB/21 (08-00)
Approved for use through 10/31/2002. OMB 0651-0031
U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE
erwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

82

TR/	NS	MI	TT	AL
	FO	RN	1	

(to be used for all correspondence after initial filing)

Application Number	10/019,458			
Application Number				
Filing Date	07/12/2002			
First Named Inventor	Roy G. Gordon			
Group Art Unit	1764			
Examiner Name	TBD			
Attorney Docket Number	42697.127US2			

Total Number of P	ages in This Submis	ssion 82	Attorney Docket	t Number	42097.127002	
		ENC	OSURES	(check	all that apply)	
Fee Transmittal Form Fee Attached Amendment / Reply After Final Affidavits/decla Extension of Time Req Express Abandonment Information Disclosure Certified Copy of Priori Document(s) Response to Missing Fincomplete Application Response to Mi	Assigni (for an Drawin Licensi Petition Provisi Power Chang Addres Termin Reque	ment Papers Application) g(s) ng-related Papers to Convert to a conal Application of Attorney, Revoca	ation	After Allowance Communication to Group Appeal Communication to Board of Appeals and Interferences Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Other Enclosure(s) (please identify below): - Postcard; Eleven (11) cited references; PTO Form 1449 RECEIVED NOV 1 4 2002 TC 1700		
	SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT					
Firm or Mary Rose Scozzafava, Ph.D. Individual name						
Signature	Signature May Rox Supplace Reg. No. 36,268					
Date	11/07/2002					
CERTIFICATE OF MAILING						

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an env lope addressed to: Commissioner for Patents, Washington, DC 20231 on this date: 11/07/2002 Rebecca S. Tinio Typed or printed name 11/07/2002 Signature Date

Burden Hour Statement: This form is estimated to take 0.2 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.





Certificate of Mailing: Date of Deposit: November 7, 2002

I hereby certify under 37 C.F.R. § 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Rebecca S. Tinio

Printed name of person mailing correspondence

Signature of person mailing correspondence

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Gordon et al.

Art Unit:

1764

Serial No.:

10/019,458

Examiner:

TBD

Filed:

July 12, 2002

Customer No.:

23483

Title:

Liquid Precursors for Formation of Materials Containing Alkali Metals

Assistant Commissioner For Patents Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449, copies of which are enclosed.

Submission of this statement is not a representation that a search has been made, nor is information included in this statement an admission that the information is material to patentability.

This statement is being filed before the receipt of a first Office action on the merits.

Applicants believe no fee is due. If there are any other charges, or any credits, please apply them to Deposit Account No. 08-0219.

RECEIVED

NOV 1 4 2002

TC 1700

Respectfully submitted,

Date: November 7, 2002

Mary Rose Scozzafava, Ph.D.

Reg. No. 36,268

Hale & Dorr, LLP 60 State Street Boston, MA 02109 Tel: (617)526-6000

Fax: (617)526-5000

Please type a plus sign (+) inside this box ->

PTO/SB/08A (08-00)
Approved for use through 10/31/2002. OMB 0651-0031
U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCI der the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 2

Complete if Known				
Application Number	10/019,458			
Filing Date	July 12, 2002			
First Named Inventor	Roy G. Gordon			
Group Art Unit	1764			
Examiner Name	TBD			
Attorney Docket Number	42697.127US2			

	U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Number (cument Kind Code ² (if known)	or Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		5,376,405		Doan et al.	12/27/1994		
		5,412,129		DiCarolis	05/02/1995		
		5,581,396		Kubota et al.	12/03/1996	<u> </u>	
		5,726,294		Rees, Jr.	03/10/1998		
		5,980,983		Gordon	11/09/1999		
						1,	
$-\!+$							
			-				
		<u> </u>	+		 		

	FOREIGN PATENT DOCUMENTS							
Examiner	or Cito			Foreign Patent Document Name of Patentee or Date of Publication		Date of Publication of	Pages, Columns, Lines, Where Relevant	
Initials*	No.1	Office ³	Number ⁴	Kind Code ⁵ (if known)	Applicant of Cited Document	Cited Document MM-DD-YYYY	Passages or Relevant Figures Appear	T6
			51: and					\vdash
						DEC	EIVED	
							<u> </u>	╁╌
						NOV	4 2002	
						TC	1700	
				- -				\vdash

Examiner	Date	
Signature	Considered	

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.



^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Please type a plus sign (+) inside this box 🗕 🗔	-
-------------------------------------------------	--------------

PTO/SB/08B (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

U. S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

The Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449B/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet of 2

Complete if Known					
Application Number	10/019,458	_			
Filing Date	July 12, 2002				
First Named Inventor	Roy G. Gordon				
Group Art Unit	1764				
Examiner Name	TBD				
Attorney Docket Number	42697.127US2				

Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. Database Registry on STN: Derwent Publication Ltd., Accession Number 113:78097, Taken from J. Heterocycl. Chem. (1989), 26(6), pp. 1771-1780. Database Registry on STN, Derwent Publication Ltd., Accession Number 107:96786, Taken from Chimia (1986), 40(6), pp. 202-205. Chikuma et al. "Waveguiding Epitaxial Potassium Lithium Niobate Single-Crystal Films Deposited by Metalorganic Chemical Vapor Deposition." Jpn. J. Appl. Phys. Vol. 37	T ²
	Taken from J. Heterocycl. Chem. (1989), 26(6), pp. 1771-1780. Database Registry on STN, Derwent Publication Ltd., Accession Number 107:96786, Taken from Chimia (1986), 40(6), pp. 202-205. Chikuma et al. "Waveguiding Epitaxial Potassium Lithium Niobate Single-Crystal Films	
	Taken from Chimia (1986), 40(6), pp. 202-205. Chikuma et al. "Waveguiding Epitaxial Potassium Lithium Niobate Single-Crystal Films	
	Chikuma et al. "Waveguiding Epitaxial Potassium Lithium Niobate Single-Crystal Films Deposited by Metalorganic Chemical Vapor Deposition." Jpn. J. Appl. Phys. Vol. 37	+
	(1998). pp. 5582-5587.	
	Feigelson. "Epitaxial Growth of Lithium Nobate Thin Films by the Solid Source MOCVD Method." J. Crystal Growth 166 (1996), pp. 1-16.	
	Tanaka et al. "Preparation of Lithium Niobate Films by Metalorganic Chemical Vapor Deposition with a Lithium Alkoxide Source." J. Crystal Growth 148 (1995), pp. 324-326.	
	Lingg et al. "Sodium Fluoride Thin Films by Chemical Vapor Deposition." Thin Solid Films, 209 (1992), pp. 9-16.	
	RECEIVED	
	TC 1700	
		Method." J. Crystal Growth 166 (1996), pp. 1-16. Tanaka et al. "Preparation of Lithium Niobate Films by Metalorganic Chemical Vapor Deposition with a Lithium Alkoxide Source." J. Crystal Growth 148 (1995), pp. 324-326. Lingg et al. "Sodium Fluoride Thin Films by Chemical Vapor Deposition." Thin Solid Films, 209 (1992), pp. 9-16. RECEIVED NOV 1 4 2002

Examiner	Date	
Signature	Considered	

¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.



^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.